ët No.: 4590-242 **PATENT**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Inventor(s): Pascal GABET et al. Confirmation No. 5672

U.S. Patent Application No. 10/722,593 : Group Art Unit: 2817

Filed: November 28, 2003 Examiner: n/a

DEVICE AND METHOD FOR FREQUENCY SYNTHESIS WITH HIGH SPECTRAL For:

PURITY

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits. No certification or fee is required.

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Respectfully submitted,

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Date: May 4, 2004

FILING

DATE

U.S. PATENT APPLICATION NO.

10/722,593

GROUP

SUBCLASS

2817

ATTY. DOCKET NO. 4590-242 INFORMATION DISCLOSURE CITATION IN AN **APPLICANT APPLICATION** Pascal GABET et al. **FILING DATE** (PTO-1449) November 28, 2003 U.S. PATENT DOCUMENTS **EXAMINER'S** INITIALS PATENT NO. DATE NAME CLASS May 29, 2001 Dekker 6,239,660

EXAMINER'S INITIALS PATENT NO. DATE COUNTRY CLASS SUBCLASS Yes No

OTHER ART (Including Author; Title; Date, Pertinent Pages, Etc.)

EXAMINER

DATE CONSIDERED

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.